

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

Applicant: Takeshi HIKATA  
Title: METHOD OF PRODUCING  
CARBON NANOSTRUCTURE  
Appl. No.: 10/591,740  
International 5/19/2005  
Filing Date:  
371(c) Date: 9/6/06  
Examiner: Roberts P. Culbert  
Art Unit: 1792  
Confirmation 3133  
Number:

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated March 31, 2009, concerning the above-referenced patent application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows: